



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 8, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG826607016

LABORATORY GROWN DIAMOND

TRIANGULAR BRILLIANT

7.24 X 7.72 X 3.73 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

1.09 CARAT

D

VVS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

EXCELLENT

EXCELLENT

NONE

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



LG826607016

PROPORTIONS

Medium To Slightly Thick (Faceted)

11.5%

33%

58%

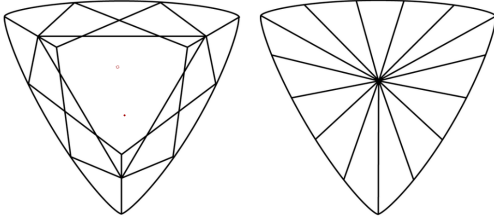
48.3%

Pointed



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included

IGI



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IGI

August 8, 2026

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TRIANGULAR BRILLIANT

7.24 X 7.72 X 3.73 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Girdle

Medium to Slightly Thick (Faceted)

Pointed

Polish

Symmetry

Fluorescence

Inscription(s)

1.09 CARAT

D

VVS 1

48.3%

85%

Medium to Slightly Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

IGI LG826607016

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